



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 3891

SERIAL NUMBER 10/579,036	FILING or 371(c) DATE 05/31/2006 RULE	CLASS 438	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. 7372/88139	
APPLICANTS Kenji Kohiro, Tsukuba-shi, JAPAN; Tomoyuki Takada, Tsukuba-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/16905 11/08/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-382116 11/12/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/09/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /FELISA CARLA HITESHEW/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 9	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 2
ADDRESS FITCH, EVEN, TABIN & FLANNERY P. O. BOX 18415 WASHINGTON, DC 20036 UNITED STATES					
TITLE Method for manufacturing compound semiconductor epitaxial substrate					
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		